	Type	Hits	Search Text	DBs
1	IS&R	3517	(438/627,643,648,650,653,656,659,683,685, 927).CCLS.	USPAT
2	BRS	143	S27 and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	USPAT
3	IS&R	2437	(257/751,761,763,764,767-770).CCLS.	USPAT
4	BRS	44	S29 and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	USPAT
5	IS&R	2447	(438/627,643,648,650,653,656,659,683,685, 927).CCLS.	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB
6	BRS	140	S31 and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB
7	IS&R	1310	(257/751,761,763,764,767-770).CCLS.	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB
8	BRS	48	S33 and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB
9	BRS	4	((multi adj layer multilayer multi-layer) near2 (barrier diffusion)) with ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	USPAT
10	BRS	6	((multi adj layer multilayer multi-layer) near2 (barrier diffusion)) with ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB
11	BRS	5	((multi adj layer multilayer multi-layer) near2 (barrier diffusion)) same ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	USPAT
12	IS&R	3	(("6147404") or ("6150720") or ("6271592")).PN.	USPAT

	Time Stamp	Comments	Error Definition	Errors	Ref #
1	2005/10/20 06:50				S27
2	2005/10/20 06:50				S28
3	2005/10/20 06:50				S29
4	2005/10/20 06:50				S30
5	2005/10/20 06:51				S31
6	2005/10/20 06:51				S32
7	2005/10/20 06:51				S33
8	2005/10/20 06:51				S34
9	2005/10/20 08:46				S37
10	2005/10/20 08:29				S38
11	2005/10/20 08:49				S40
12	2005/10/20 08:49				S41

	Type	Hits	Search Text	DBs
13	BRS	5	((multi adj layer multilayer multi-layer multilayered) near2 (barrier diffusion)) same ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	USPAT
14	BRS	5	(((multi adj layer multilayer multi-layer multilayered) near2 (barrier diffusion)) and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))).clm.	US-PGPUB
15	BRS	77	S45 and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	USPAT
16	BRS	53	S47 and ((atomic adj layer adj chemical adj vapor adj deposition atomic adj layer adj deposition) (alcvd ald))	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB
17	IS&R	1093	(438/687).CCLS.	USPAT
18	IS&R	503	(438/687).CCLS.	US-PGPUB; USOCR; EPO; JPO; DERWENT; IBM_TDB

	Time Stamp	Comments	Error Definition	Errors	Ref #
13	2005/10/20 08:59				S42
14	2005/10/20 08:59				S44
15	2005/10/31 07:05				S46
16	2005/10/31 07:05				S48
17	2005/10/31 07:09				S45
18	2005/10/31 07:10				S47